

Application No. 10/552,677
Response To After Final Office Action of January 14, 2010

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4/12/10
Docket No.: RPP 202-US (10510421)

Amendment After Final Action Under 37 C.F.R. 1.116	
I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted via the Office electronic filing system in accordance with § 1.6(a)(4).	
Dated: 4/7/10	Signature: Fani Malikouzakis (Fani Malikouzakis)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Rudolf Beckmann

Application No.: 10/552,677

Confirmation No.: 2418

Filed: November 21, 2005

Art Unit: 1792

For: HIGH FREQUENCY PLASMA JET
SOURCE AND METHOD FOR
IRRADIATING A SURFACE

Examiner: Not Yet Assigned

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Final Office Action dated January 14, 2010, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.